

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:

Jackwang CHOI et al.

CONF. NO.: 2759

SERIAL NO.:

10/807,139

GROUP:

1763

FILED:

March 24, 2004

EXAMINER: George A. GOU

FOR:

SLURRY COMPOSITIONS AND CHEMICAL MECHANICAL

POLISHING METHOD USING THE SAME

DOCKET NO.:

2557-000215/US

AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.116

June 5, 2006

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 Mail Stop AF

Dear Sir:

Responsive to the Final Office Action ("Action") dated April 5, 2006, the following amendments and remarks are submitted in connection with the above-referenced application. The sections included in this response are as follows:

> Amendments to the Claims begin on page 2 of this paper; and a Remarks section begins on page 15 of this paper.

| 144 Y 15 Y | Claims remaining after Amendment | | Highest number previously paid for | | Present extra |
|-------------|----------------------------------|---|------------------------------------|---|---------------|
| Total | 38 | - | 38 | = | 0 |
| Independent | 5 | _ | 5 | = | 0 |